

**APPLICATION DATA SHEET**

Electronic Version v14

Stylesheet Version v14.0

<b>Title of Invention</b>	Method of Fabricating Patterned Polymer Film With Nanometer Scale
Application Type: regular, utility Attorney Docket Number: 2236.0030000/JUK/GSB	
Correspondence address: <b>Customer Number:</b> 26111 *26111*	
Priority Data: Doc.No: 2003-42676; Country - KR; Date: 2003-06-27 us-priority-claimed	
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as our attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.

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